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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Number: 09/519,165
Filing Date: 03/06/2000
Applicants: Sherrer, et al.
Application Title: Single Mask Lithographic Process for
Patterning Multiple Types of surface
Features
Examiner: William P. Watkin, III
Art Unit: 1772
Docket No.: ACT-111

Commissioner of Patents and Trademarks
Washington, DC 20231

Sir:

AMENDMENT A

In response to the office action mailed 07/17/01, kindly amend the above application as follows:

DRAWINGS: No Changes

SPECIFICATION: No Changes

CLAIMS: Please amend claim 13. ✓
Please add claims 19-29.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, DC 20231, on

11/16/01

Date of Deposit

Diane Hughes

Diane Hughes

11/16/01

Date